



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :

Hatakeyama et al.

Group Art Unit: 1752 ✓

Serial No.: 09/994,808

Examiner: LEE, Sin J.

Filed: November 28, 2001

RECEIVED  
DEC 15 2003  
TC 1700

For: AMINE COMPOUNDS, RESIST COMPOSITIONS AND PATTERNING PROCESS

**REPLY**

Mail Stop Non Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR:

In response to the Office Action mailed on September 10, 2003, please amend the claims as follows and consider the remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 13 of this paper.